



CS-02-012

October 27, 2003



To: Commissioner for Patents  
P.O.Box 1450  
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572  
28 Davis Avenue  
Poughkeepsie, N.Y. 12603

Subject:

Serial No. 10/633,131 08/01/03

Alvaro Maury et al.

ZONE POLISHING USING VARIABLE  
SLURRY SOLID CONTENT

Grp. Art Unit:

#### INFORMATION DISCLOSURE STATEMENT

Enclosed is Form PTO-1449, Information Disclosure Citation  
In An Application.


The following Patents and/or Publications are submitted to  
comply with the duty of disclosure under CFR 1.97-1.99 and  
37 CFR 1.56. Copies of each document is included herewith.

#### CERTIFICATE OF MAILING

I hereby certify that this correspondence is being  
deposited with the United States Postal Service as first class  
mail in an envelope addressed to: Commissioner for Patents,  
P.O. Box 1450, Alexandria, VA 22313-1450, on October 27, 2003.

Stephen B. Ackerman, Reg.# 37761

Signature/Date

 10/27/03

CS-02-012

U.S. Patent 6,398,627 to Chiou et al., "Slurry Dispenser Having Multiple Adjustable Nozzles," describes a slurry dispenser having multiple adjustable nozzles.

U.S. Patent 6,234,877 to Koos et al., "Method of Chemical Mechanical Polishing," discloses a CMP tool with adjacent slurry and diluting solution dispensers.

U.S. Patent 6,106,728 to Iida et al., "Slurry Recycling System and Method for CMP Apparatus," discloses a CMP apparatus.

U.S. Patent 5,658,185 to Morgan, III et al., "Chemical-Mechanical Polishing Apparatus with Slurry Removal System and Method," discloses a CMP apparatus.

Sincerely,

A handwritten signature in black ink, appearing to read "SBA", with a long horizontal flourish extending to the right.

Stephen B. Ackerman,  
Reg. No. 37761

Form PTO-1449

INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

(Use several sheets if necessary)

Document Number (Sequence)

CS-02-012

Application Number

10/633,131

Applicant

Alvaro Maury et al.

Filing Date

08/01/03

Draws Sheet(s)

## U. S. PATENT DOCUMENTS

EXAMINER	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
	6398627	6/4/02	Chiou et al.	451	72	3/22/01
	6234877	5/22/01	Koos et al.	451	41	6/7/00
	6106728	8/22/00	Iida et al.	210	743	6/23/98
	5658185	8/19/97	Morgan, III et al.	451	36	10/25/95

## FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.